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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaki KATO et al.

Group Art Unit: 2851

Application No.: 09/828,914

Examiner: H. Nguyen

Filed: April 10, 2001

Docket No.: 109187

For: EXPOSURE APPARATUS, METHOD FOR MANUFACTURING THEREOF AND
METHOD FOR MANUFACTURING MICRODEVICE

AMENDMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In reply to the Office Action dated November 8, 2002, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

IN THE DRAWINGS:

Please amend Fig. 1 as set forth in the Request for Approval of Drawing Corrections filed herewith.

IN THE ABSTRACT:

Please replace the Abstract with the substitute Abstract attached hereto.

IN THE CLAIMS:

Please cancel claims 46-66 without prejudice to or disclaimer of the subject matter contained therein. Applicants reserve the right to file one or more divisional applications to pursue the subject matter of these non-elected claims, which have been withdrawn in the

Office Action.

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